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APR 13 2006

**METHOD OF FABRICATING SILICON CARBIDE-CAPPED COPPER
DAMASCENE INTERCONNECT**

Appl. No. : 10/711,015 Confirmation No. 5014
Applicant : Jei-Ming Chen,
Chin-Hsiang Lin,
Chih-Chien Liu,
Kuo-Chih Lai
Filed : August 18, 2004
TC/A.U. : 2826
Examiner : Quinto, Kevin V
Docket No. : NAUP0596USA0
Customer No. : 27765

Commissioner for Patents

P.O. Box 1450

Alexandria VA 22313-1450

Subject: Request for Continued Examination (RCE) in response to the advisory
5 action mailed 03/15/2006

INTRODUCTORY COMMENTS

10 In response to the Office action identified above, a request for continued
examination (RCE) is made and the above-identified application is to be amended as
indicated in the following sections. No new matter has been introduced by these
amendments. A continued examination and consideration of all amendments are politely
requested.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this
paper.

Remarks begin on page 5 of this paper.